

<u>ASSIGNMENT</u>	<u>CESION</u>
HÄBERLE, Hans; BURCKHARDT, Urs	HÄBERLE, Hans; BURCKHARDT, Urs
by means of this document assign to SIKA TECHNOLOGY AG	by means of this document assign to SIKA TECHNOLOGY AG
A company organized under the laws of Switzerland	Una compañía organizada bajo las leyes de Suiza
Domiciled in Zugerstrasse 50 6340 Baar, Switzerland	domiciliada en Zugerstrasse 50 6340 Baar, Suiza
all our rights, title and interest in and to our invention for a new and useful improvement entitled and as fully set forth and described in: LOW-EMISSION LIQUID FILM FOR SEALING BUILDINGS	todos nuestros derechos, títulos e intereses sobre y para nuestra invención referente a una mejora nueva y útil titulada y como se expone y describe en: PELÍCULA LÍQUIDA DE BAJA EMISIÓN PARA SELLAR EDIFICIOS
Given and signed this <u>6th August</u> , 2018 in <u>Zurich</u> by Signature  HÄBERLE, Hans;  BURCKHARDT, Urs	Dado y firmado hoy <u>6th August</u> 2018 en <u>Zurich</u> por Firma  HÄBERLE, Hans;  BURCKHARDT, Urs

This document does not need legalization. Please send us this document signed by the inventors by email.